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Patent Application of: Michael Weber-Grabau, et al.

Atty Docket No. TTI-31000

Application No.: 09/927,102

Filed: August 10, 2001

Confirmation No.: 3815

For:

CRITICAL DIMENSION METROLOGY SYSTEM INTEGRATED INTO SEMICONDUCTOR WAFER

PROCESS TOOL

M/S AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS		HIGHEST NO.	PRESENT	RATE	ADDITIONAL
	REMAINING		PREVIOUSLY	EXTRA		FEE
	AFTER		PAID FOR			
	AMENDMENT			_		_
TOTAL	18	MINUS	44	0	x \$50 =	\$0.00
INDEP.	3	MINUS	6	0	x \$200=	\$0.00
FIRST PRI	ESENTATION OF MU	+ \$360	\$0.00			
	-				TOTAL	00.02

TOTAL \$0.00

Small Entity 50% Filing Fee Reduction (if applicable)

*	If the entry in Col.	l is less than the entry	in Col. 2, write	"0" in Col. 3

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

- If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)
- 1. No additional fee is required.
- \boxtimes 2. Applicant(s) hereby petition(s) for a two-month extension of time in which to file the present response and enclose(s) herewith the necessary fee to accompany this petition. A check in the amount of \$450.00 is attached.
- \boxtimes Please charge any additional fees, including any fees necessary for extensions of time or credit 3. overpayment to Deposit Account No. 50-1703, under Order No. TTI-31000. A duplicate copy of this sheet is enclosed.

STALLMAN & POLLOCK LLP

Dated:	April 4, 2006	By: Unil J. Block	
_		Michael J. Pollock (Reg. No. 29,098)	_
		Attorneys for Applicant(s)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 April 4, 2006.

Dated: <u>04/04/06</u>